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Docket No.: M4065.0735/P735  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Jin Li

Application No.: 10/653,222

Confirmation No.: 2741

Filed: September 3, 2003

Art Unit: 2815

For: MICROLENSSES FOR IMAGING DEVICES

Examiner: Nguyen, Joseph H.

**RESPONSE TO RESTRICTION REQUIREMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed May 9, 2006, Applicants hereby elect Group I for continued examination, without traverse.

Dated: May 23, 2006

Respectfully submitted,

By 

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